

主として、... 併設の... 化

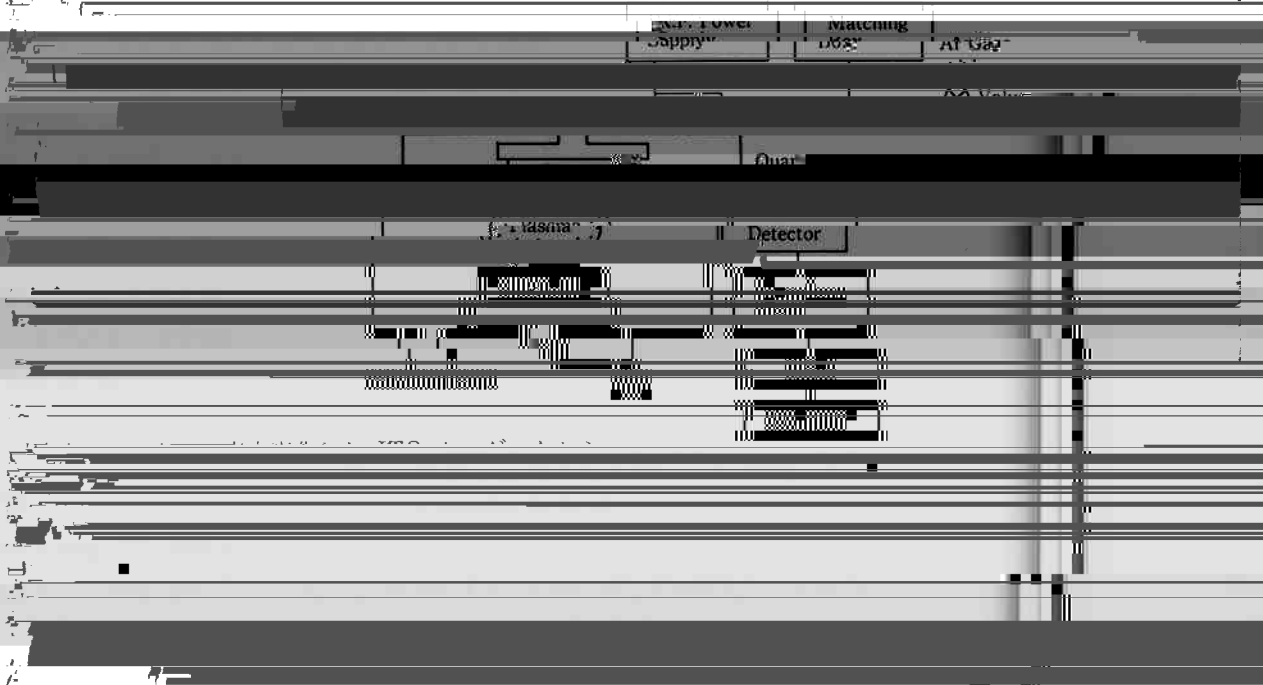


Figure 1: A schematic diagram of the experimental setup. The diagram shows a power supply connected to a matching network, which is connected to an Ar gas inlet. The matching network is connected to a quartz chamber containing a target and a detector. The target is connected to the power supply, and the detector is connected to the matching network. The diagram also shows a quartz chamber containing a target and a detector.

Figure 1: A schematic diagram of the experimental setup.

Figure 2: A schematic diagram of the experimental setup. The diagram shows a power supply connected to a matching network, which is connected to an Ar gas inlet. The matching network is connected to a quartz chamber containing a target and a detector. The target is connected to the power supply, and the detector is connected to the matching network. The diagram also shows a quartz chamber containing a target and a detector.

今回、このような ITO ターゲットの高密度化による

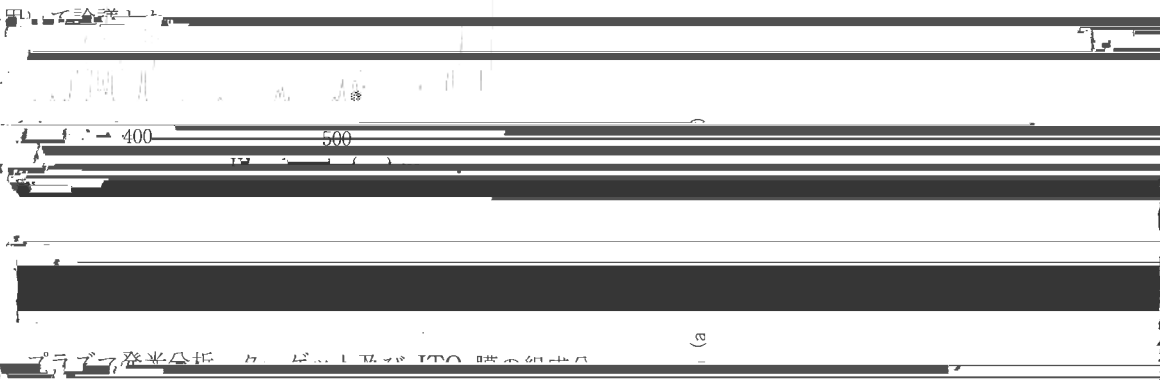
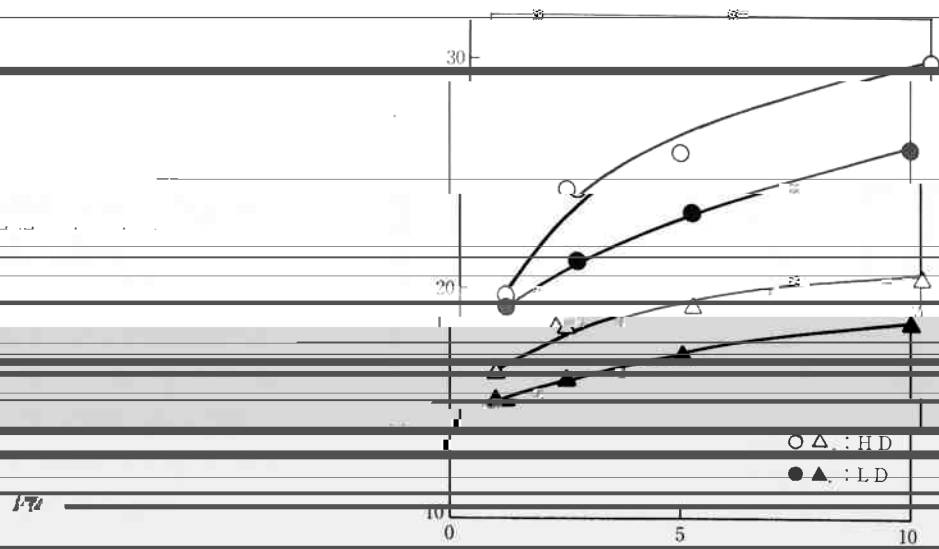


Fig. 2. The ...

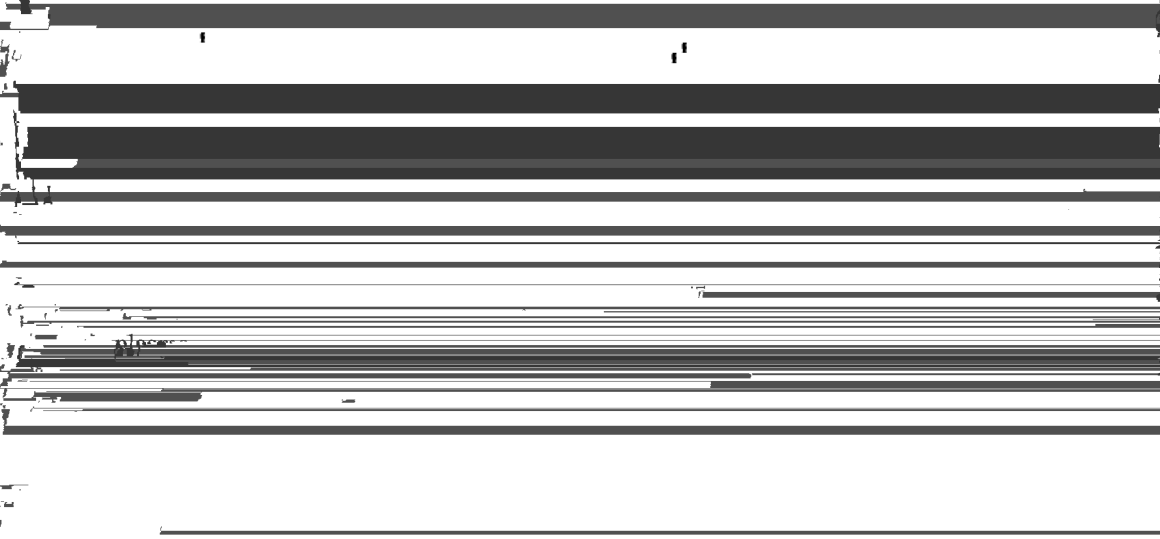


Fig. 2. The ...

O₂ Emission (a.u.)

30

0.7

14

e O₂/In Ratio

0.6

1.2

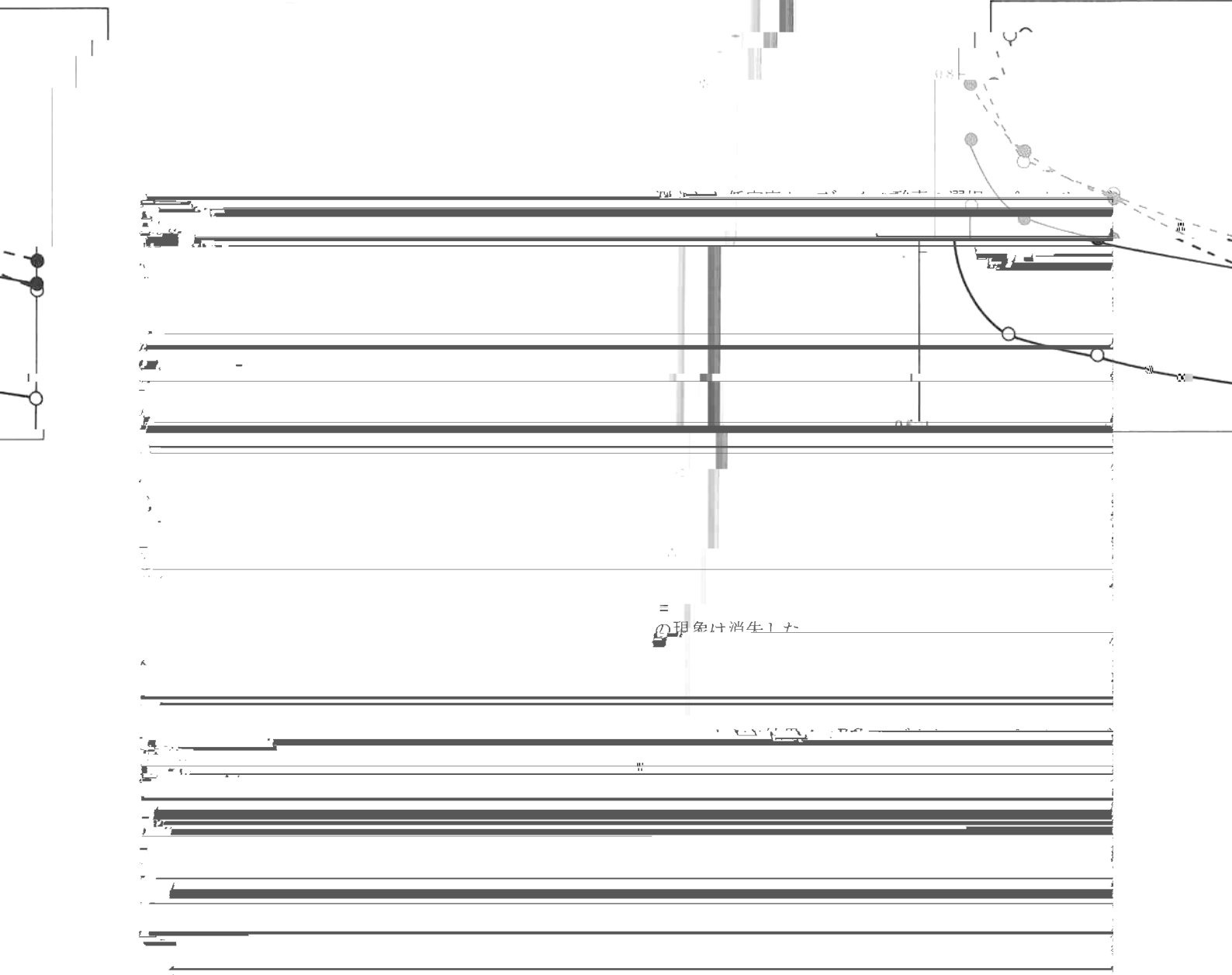
O₂/In Ratio

60 70 80 90

Intensity

20

12



① 現象計測生じた



Fig. 8. The electro-chemical characteristics of ITO

after sputtering (---) for Redox reaction

10)

CRSSPS 5(3) .112 (1000)

